

06/24/02 2811

Attorney Docket No.: NECF 18.591

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Takaaki NAGAI

Serial No.: 09/837,734

Filed: JUN 20 2002 April 17, 2001

Title: NON-VOLATILE SEMICONDUCTOR STORAGE  
APPARATUS AND MANUFACTURING METHOD THEREOF

Examiner: Douglas W. Owens

Group Art Unit: 2811

Assistant Commission for Patents  
Washington, D.C. 20231

CHANGE IN CORRESPONDENCE ADDRESS

SIR :

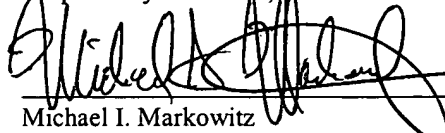
It is respectfully requested that any future correspondence regarding the above-referenced application be directed to Applicant's attorneys (previously appointed) at the following new correspondence address:

Katten Muchin Zavis Rosenman  
575 Madison Avenue  
New York, New York 10022  
Phone: (212) 940-8800  
Fax: (212) 940-8986 or (212) 940-8987

Any inquiries regarding this change in address may be directed to the Applicant's undersigned attorney at the above-referenced telephone numbers.

Our CUSTOMER NUMBER 026304 remains the same.

Respectfully submitted,

  
Michael I. Markowitz  
Reg. No. 30,659

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KATTEN MUCHIN ZAVIS ROSENMAN  
575 MADISON AVENUE  
NEW YORK, NEW YORK 10022  
(212) 940-8687  
DOCKET NO.:NECF 18.591

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